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**U.S. PATENT DOCUMENTS**

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
DHM	*	2001002486		Kocher et al.	2001.05
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**FOREIGN PATENT DOCUMENTS**

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y/N)
		Office/Country	Number	Kind Code			
DHM		FR	2799851	A	Caron (English Abstract)	04/202001	

**OTHER ART — NON PATENT LITERATURE DOCUMENTS**

Examiner's Initials	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)	
DHM		French Search Report from corresponding French priority application No. 02/11671		
DHM		Bajard, J-C, et al., <u>Modular Multiplication and Base Extensions in Residue Number Systems</u> , Proceedings 15 <sup>th</sup> IEEE Symposium on Computer Arithmetic, Vail, Co, June 11-13, 2001, IEEE Symposium on Computer Arithmetic, US, Los Alamitos, IEEE Comp. Soc. June 11, 2001, pp 59-65, XP-010547810		
DHM		Yens, M. et al., <u>RSA Speedup with Residue Number System Immune Against Hardware Fault Cryptanalysis</u> , Lecture Notes in Computer Science, Springer Verlag, New York, NY vol, 2288, December 7, 2001, pp 397-413, XP002233842		

<b>EXAMINER</b> /David Malsahn/	<b>DATE CONSIDERED</b> 10/18/2006
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